#### Lifetime of the CDF RunII Silicon

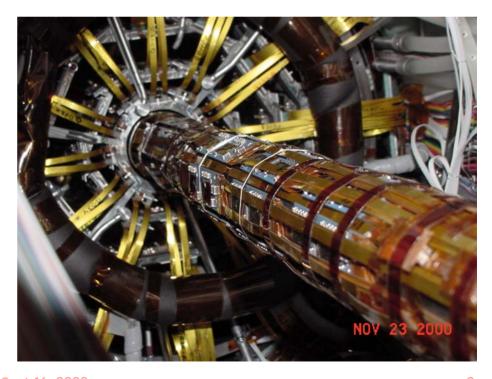


Steven Worm
Rutgers University

(with help from the CDF Radiation Monitoring and CDF Silicon Groups)

#### Outline

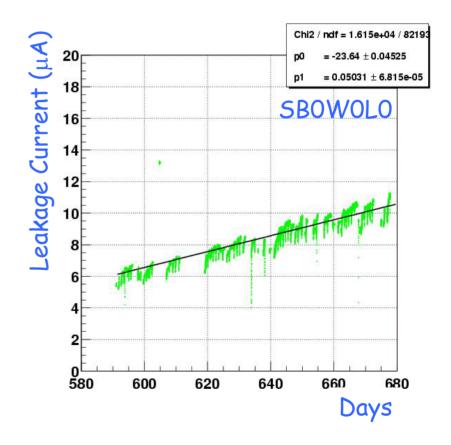
- o Is the CDF silicon measurably damaged by radiation?
- Measuring the radiation field
  - Leakage current measurements
  - TLD measurements from the tracking volume
  - Depletion voltage measured from noise
- Lifetime of the Run IIa silicon
  - How does the silicon 'die'?
  - Signal
  - Noise
  - Degradation in b-tagging
- o How long can it live?
- o Conclusions



# Is there measurable Radiation Damage at CDF? (YES!)

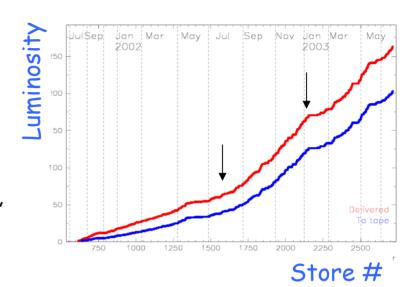
- Leakage current increases from surface and bulk damage
- Depletion voltage changes too...

We now have both radiation damaged silicon from a hadron collider environment, and models with which to compare



### Leakage Current vs Integrated Luminosity

- 326 pb<sup>-1</sup> delivered to CDF
- Current vs Luminosity well measured
  - measured for a stable run period
  - 100.7 pb<sup>-1</sup>, from 8/15/02 to 1/21/03
  - Large variations seen module-to-module, especially for Micron sensors
  - Using (guard+bias)/volume



	ΔΙ/ ladder [μ <b>Α</b> ]	RMS [μ <b>A</b> ]	Fluence 1 MeV n 1E12 /cm²/fb <sup>-1</sup>	
Layer 00 narrow	4.89	1.57	30	
Layer 00 wide	6.47	1.93	20	
Layer O	10	1.99	9.3	
Layer 1	8.1	2.00	5.1	
Layer 2	5.2	2.94	2.4	
Layer 3	5.88	1.60	1.8	
Layer 4	4.37	2.41	1.2	

#### Run II Measurements vs. Run I Predictions

#### o Predictions from Run I vs. recent measurements

- Currents measured in Run Ia and Run Ib average to be

```
I(24C,3cm) = 0.69\pm0.11 \text{ nA/strip/pb}^{-1}
```

- Using  $\alpha$  = (3.0±1.0)x10<sup>-17</sup>A/cm and scaling temperature, we predict

```
\Phi(1\text{MeVn,LO}) = (0.50\pm0.16)\times10^{13} 1\text{MeVn/cm}^2/\text{fb}^{-1}
```

Measurement from Run II is

```
\Phi(1\text{MeVn,L0}) = (0.93\pm0.26)\times10^{13} 1\text{MeVn/cm}^2/\text{fb}^{-1}
```

- Why are they different? Not sure, but...
  - CDF has been substantially reconfigured
  - Run II detector has much more material
  - Errors are still large; difference is only ~25
  - We are colder now, should probably use different alpha...
- o What does this mean for the LHC?
  - Had been quoting CDF Run I measurements as check of simulations
  - LHC has more/different material

### Noise as a measure of Depletion Voltage?

- Noise drops on n-side as Si is depleted
  - With double-sided silicon, might provide convenient monitor of Vdep
  - Operating voltages set to 20V (5V) above Vdep for Hamamatsu (Micron) Silicon
  - Can be automated and measured quickly, without collisions
  - "dnoise" = common mode subtracted noise
- o Several measurements made:

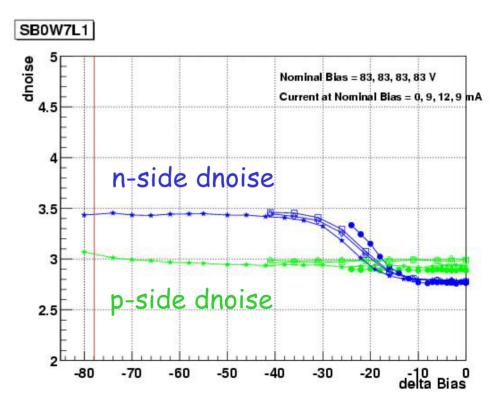
Mar • 179 pb<sup>-1</sup>

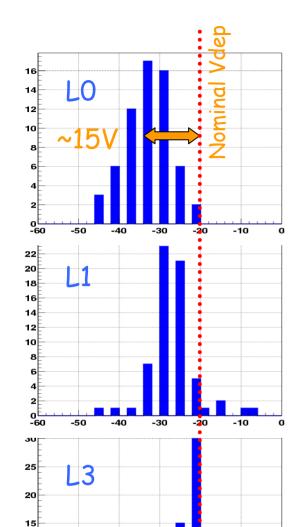
July □ 273 pb<sup>-1</sup>

Aug +  $302 \text{ pb}^{-1}$ 

Sept \* 326 pb-1

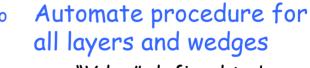
Differences with CV and signal collection under study





#### n-side Noise vs Bias scans

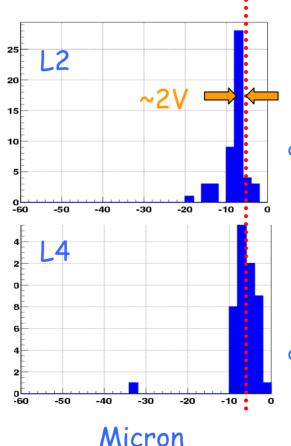
(preliminary results)



- "Vdep" defined to be noise increase by >4%
- Data for all layers of ISL, SVX

#### Change in Vdep Evident

- Nominal settings are vendor CV +20V (+5V) for Hamamatsu (Micron)
- LO shows average 15V decrease in Vdep
- Charge collection vs Vdep and LOO changes to be studied with signal scan



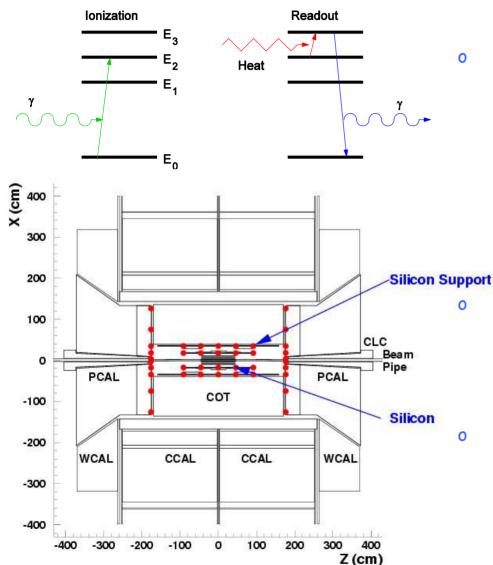
Hamamatsu

10

-50

Steven Worm - Rutgers Sept 16, 2003

### Measuring the Radiation Field: TLDs



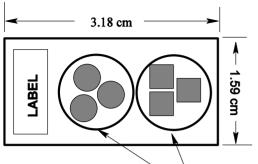
- Thermo-luminescent Dosimeters (TLDs) have many advantages
  - Industry standard
  - Passive devices
  - Large range (mRad to 0.2 Mrad)
  - Excellent accuracy; 3% chip-tochip variation, 1% reproducibiliy

#### They also have some drawbacks

- Require a lot of handing
- Must be 'harvested' and read out

TLDs with sensitivity to ionizing particles or neutrons are available.

### Tracking Volume TLDs



TLDs with  $^{7}$ Li,  $^{6}$ Li Sensitive to  $\gamma$ , n



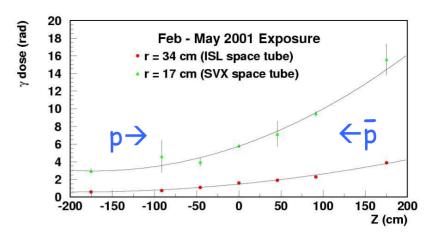
- TLD holders attached to kapton film and pulled into place like a 'clothesline'
- Kapton leads fed through cables for silicon and drift chamber
- Finding the ends can be difficult!

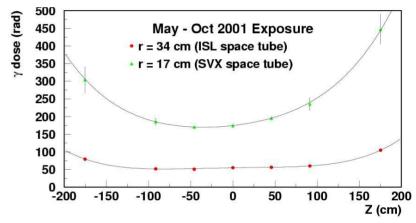
#### TLD data

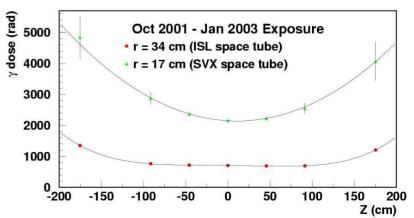
#### Data from three exposure periods

- First one during loss-dominated period
- Second period was a mix of losses and collisions
- Final measurement almost all collisions

	Fraction of Dose	Integrated	
Period	From Losses (%)	Lum (pb <sup>-1</sup> )	
Feb 01 - May 01	80-90	0.06	
May 01 - Oct 01	15-25	10.7	
Oct 01 - Jan 03	5-10	159	



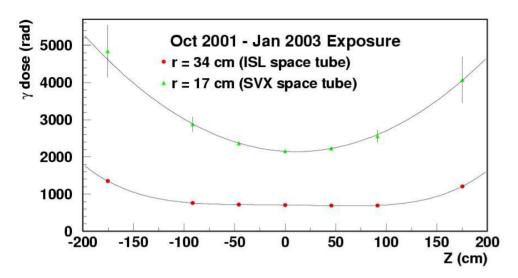


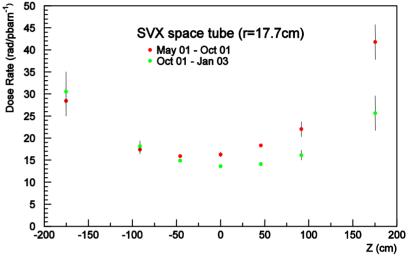


### Latest TLD results

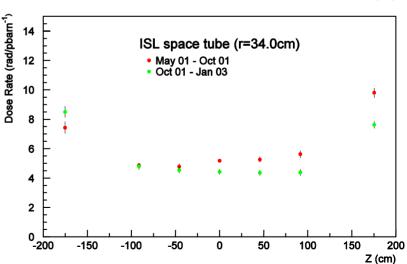
(preliminary)







- New measurement over long stable data taking period
- Last two measurements compare well
  - May 2001 to Oct 2001 (10.7 pb<sup>-1</sup>)
  - Oct 2001 to Jan 2003 (159 pb<sup>-1</sup>)
  - Raw ionizing radiation dose rates vs. z are very similar



### "Death" of the Silicon; Modeling the S/N

- We expect that the inner silicon layers will eventually be unusable due to low 5/N
  - Displaced track triggering will be good to S/N = 8.
  - B-tagging will be degraded at low S/N (in Run I,  $\varepsilon$  was lost below S/N ~6)

#### o Noise

- Shot noise calculated from leakage current
- Chip noise measured in controlled irradiations

#### o Signal

- Double-sided AC-coupled silicon  $\rightarrow$  voltage across readout caps
- ~170V maximum depletion, from burn-in (180V) and other concerns
- Axial strips are on p-side; can't get axial info while underdepleted
- Depletion voltage estimates are therefore critical
- We assume full charge collection throughout Run II

### Noise Model for CDF

#### Shot noise

- Shot noise (108 ns int time) is given by

```
Q_{shot} = 900e x sqrt(I(\muA))
I<sub>LO</sub> = 0.39 nA/strip/pb<sup>-1</sup>
```

- Radial scaling is estimated by using the TLD central data  $(1/r^{1.590\pm0.008})$ 

#### o Chip noise

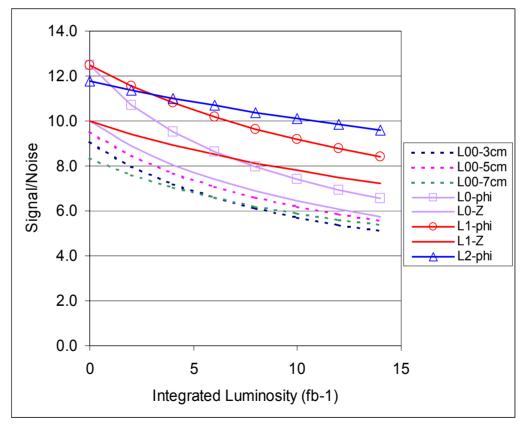
- Chip noise varied from 52 to 100 e<sup>-</sup>/pF in 0-15 Mrad
- Zero-load noise varied from 650 to 1100 e- in 0-15 Mrad
- o Inputs to model of leakage vs dose and initial noise now well measured

#### Sample values for 4 fb<sup>-1</sup>:

Layer	Luminosity	Shot	Chip	Shot+Chip	S/N(20ke <sup>-</sup> )	noise (ADC)
L0-phi	4	1125	1740	2072	9.7	3.5
L0-Z	4	1124	2175	2449	8.2	4.1
L1-phi	4	776	1665	1837	10.9	3.1
L1-Z	4	776	2081	2221	9.0	3.7

### Noise Model; Results

- Noise degrades more steeply at first, then gradually
- 5/N follows same trend (assuming full signal collection) and does not quite reach 6 for LO.



S/N begins near 12.5, and is expected to decline gradually

### Depletion Voltage Model

We parameterize the Depletion Voltage in three parts (Hamburg model):

$$\Delta N_{eff}(T,t,\Phi) = N_A + N_C + N_Y$$

o Short term annealing  $(N_A)$ 

$$N_A = \Phi_{eq} \sum_{i} g_{a,i} \exp(-k_{a,i}(T)t)$$

- Reduces N<sub>y</sub> (beneficial)
- Time constant is a few days at 20 C
- o Stable component  $(N_c)$

$$N_c = N_{c0}(1-\exp(-c\Phi_{eq}))+g_c\Phi_{eq}$$

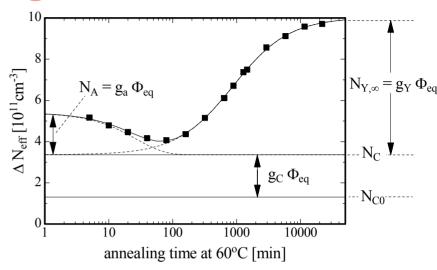


Fig.13: Annealing behaviour of the radiation induced change in the effective doping concentration  $\Delta N_{eff}$  at 60°C.

- Does not anneal (does not depend on time or temperature)
- Partial donor removal (exponential or limited exponential)
- Creation of acceptor sites (linear)
- $\circ$  Long term reverse annealing  $(N_y)$

$$N_y = N_{y,\infty}[1-1/(1+N_{y,\infty}k_y(T)+)], N_{y,\infty}=g_y\Phi_{eq}$$

- Strong temperature dependance
- Can be significant long term; must cool Si

### Depletion Voltage Model - cont.

- Estimated overvoltage is included
  - We use a geometric model to estimate overvoltage [SCIPP 93/16];

```
Vdep = Vplanar(1+(p/d)F(w/p))

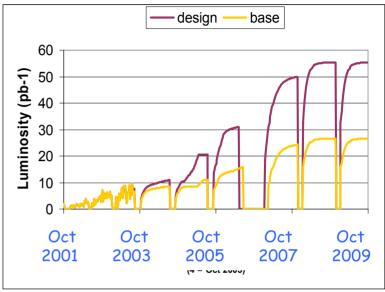
F(x) = -0.00111x^{-2} + 0.0586x^{-1} + 0.240 - 0.651x + 0.3555x^{2}
```

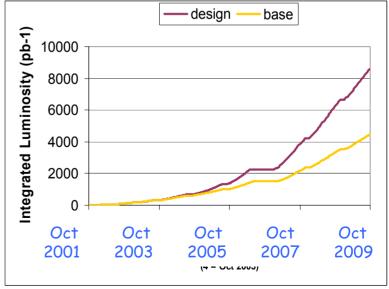
- Provides a large multiplicative factor for CV (Vplanar), especially with narrow strips with wide pitches
- Long term (reverse) annealing is significant only at the end of the run

Parameter	Value
$g_{y}$ [10 <sup>-2</sup> cm <sup>-1</sup> ]	4.6 ± 0.3
$g_c$ [10 <sup>-2</sup> cm <sup>-1</sup> ]	1.77 ± 0.07
$N_{C0}$ [ $10^{11}$ cm $^{-3}$ ]	5.0 ± 0.2
E <sub>a</sub> [eV]	1.31 ± 0.04
c [10 <sup>-13</sup> cm <sup>2</sup> ]	2.0

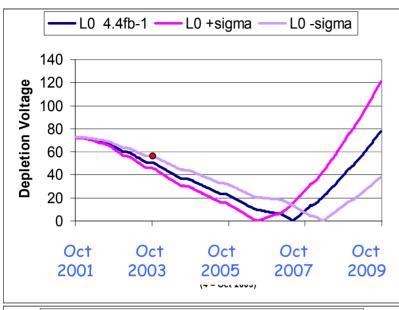
### Luminosity and Temperature Model

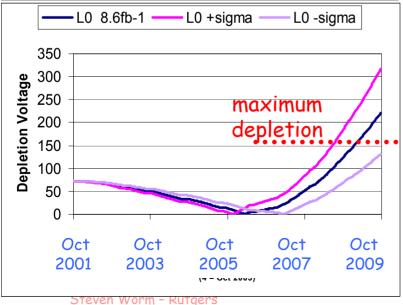
- Luminosity Model provided by the Tevatron Beams Division (July '03)
  - "Design" goal is ~6.5 fb<sup>-1</sup> by mid 2008
  - "Base" goal is  $\sim$ 3.6 fb<sup>-1</sup> by mid 2008
  - Expected shutdown periods included
  - Numbers are far more realistic than in the past... unfortunately also lower
- Temperature modeled on current operating conditions
  - Chiller temperature is -6 °C
  - Warm parts of SVXII silicon are 12±2 °C cold, 16 °C warm (design temperature)
  - We can probably go colder





### Depletion Voltage Results





#### o Results for "Base" luminosity

- Indicates full depletion throughout RunIIa
- Bands indicate approximate errors
- Red dot is measurement from noise study

## Results for "Design" luminosity (assumes reasonable TeVatron improvement)

- Silicon inner layer will die from radiation
- Long term annealing becomes important
- Errors are rather large, driven by large ladder to ladder RMS

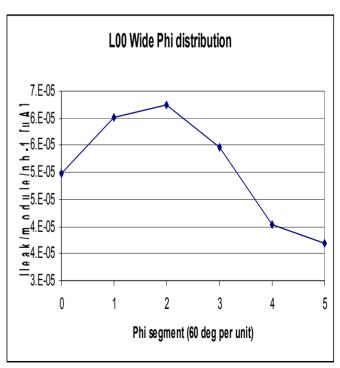
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### An example "Real World" effect: Beam Offset

- The CDF detector and Tevatron beam are not perfectly co-axial Assuming a 1/r<sup>1.6</sup> radial dependence, the top sensors of LOO receive ~50% more radiation than the bottom ones.
- Offset will be corrected in an upcoming shutdown

	×[mm]	y [mm]	x' [μr]	y' [μr]
SVXII	-1.0625	1.5003	756	-314
Beam	-1.8	4.5	600	100
difference	-0.74	3.00	-156	414

The models can be used as a guide, but the errors are often larger in the "real world"



### Will the CDF Silicon "Age Gracefully"?

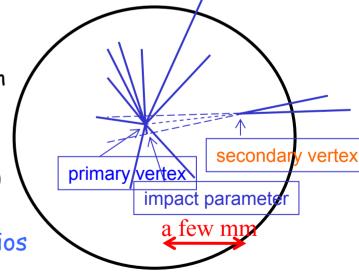
We use simulation to study the degradation in tracking and b-tagging performance vs. integrated luminosity.

- o Generate  $t\bar{t} \rightarrow Wb(Wb)$  events and use CDF detector simulation
- To degrade the simulation we
  - Add shot and chip noise on all strips, according to expectations
  - Degrade resolution with noise
  - Recluster the silicon strips with new thresholds
  - Assume no trapping and full depletion
  - Remove Si layers as they 'die' from underdepletion
- Measure how often a b quark in the detector results in a 'tag'

(nb: not a quantity the physics groups usually look at)

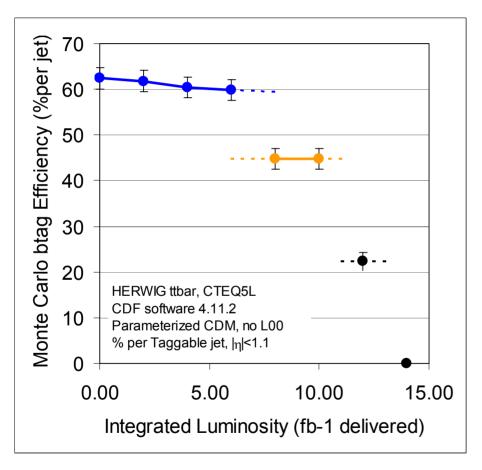
 $\varepsilon$  = #tagged b's / #b's

Iterate over different radiation damage scenarios



### Degradation in b-tag efficiency

(preliminary results)



#### Secondary Vertex Tagging (b jets)

- HERWIG Monte Carlo study
- Secondary vertex (b) tagged events
- Remove LO from tracking at 6-8 fb<sup>-1</sup> (orange points)
- Remove L1 at 10-12 fb<sup>-1</sup>

#### o Requirements:

- b is in the detector ( $|\eta| < 1.1$ )
- b yields a jet w/ at least two tracks

#### LOO not included

- Not yet in the 'default' tracking
- Not studied yet for tagging

#### Results

- efficiency still good after S/N degraded
- L00 must be fully integrated and must survive to maintain tag efficiency

#### Conclusion

We now have Run II radiation measurements and models of S/N to compare

Assuming reasonable luminosity, we expect LO will 'die' from underdepletion

The Run IIa silicon should continue to provide good vertex information until (at least) 6 fb<sup>-1</sup>.

CDF Run IIa silicon was designed for 2 fb-1 and 2 years of operation...

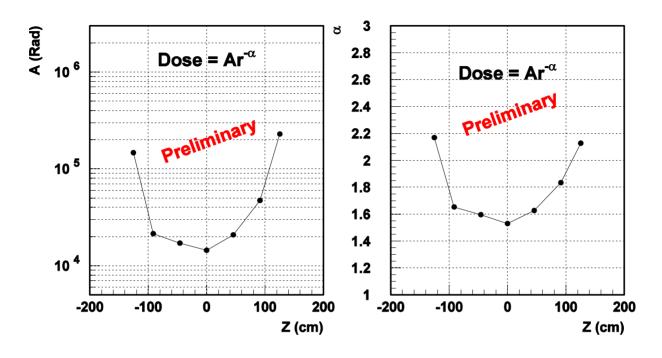
Two years done, only 6 more years to go!

### Backup - DO vs CDF

- o DO should live to "at least 4 fb-1", CDF to 6fb-1, but...
  - D0 is ~10 °C colder
  - D0 inner layer is at 3cm, CDF is at 2.5cm

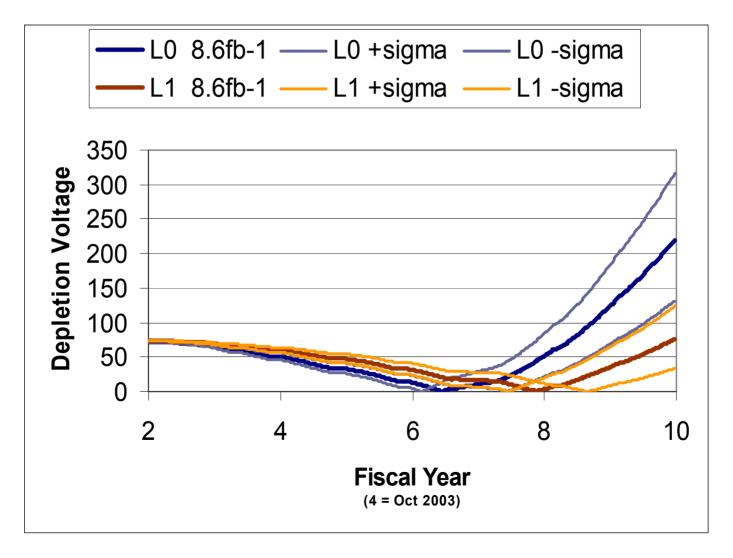
- Some things to consider are...
  - Resistivity differs in inner layer (Micron vs. Hamamatsu)
    - Initial Vdep for D0 is 20-30V
    - Initial Vdep for CDF is 70-80V
  - 170V depletion for CDF without problems, less for DO
    - · Microdischarge problems on one side due to alignment of implant and metal
    - Burn-in voltages lower?? (not sure...)
  - 7-8 barrel layers for CDF, much less for DO
  - Different models for Vdep

### Backup - Losses/Beam Detail

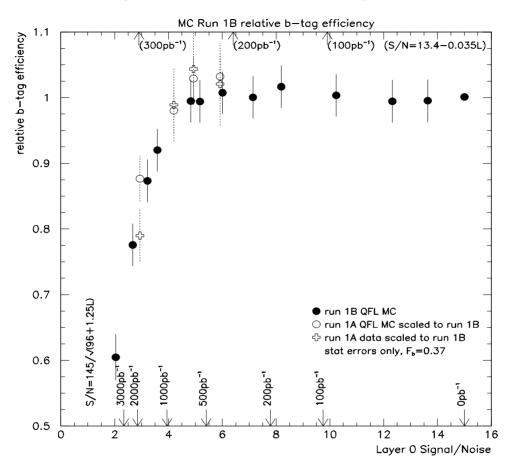


	Beam (x10 <sup>19</sup> )	Losses (x10 <sup>9</sup> )	Integrated	
Period	рр	рр	Lum (pb <sup>-1</sup> )	
Feb 01 - May 01	0.07 0.008	15.3 2.0	0.06	
May 01 - Oct 01	1.56 0.14	40.9 10.2	10.7	
Oct 01 - Jan 03	9.65 0.657	621 440	159	

### Backup - Vdep L1 Model



### Backup - RunI b-Tag vs S/N



Types 1: 193' I by efficiency corner 193 or Retended with the constant the first plantation. However, and providing provide the plantation of 183 or 183 or 184 because the plantation of 183 or 184 because the plantation of 183 or 184 because the plantation of 184 or 184 because the plantation of 184 or 184 or

### Backup - Resolutions (input to Monte Carlo)

	phi-side resolutions			z-side resolutions				
layer	1-strip	2-strip	3-strip	4-strip	1-strip	2-strip	3-strip	4-strip
(	0.0011	0.0009	0.0019	0.0019	0	0	0	0
1	0.0013	0.0011	0.0023	0.0023	0.0031	0.0026	0.0054	0.0054
2	0.0013	0.0011	0.0024	0.0024	0.0027	0.0023	0.0048	0.0048
3	0.0013	0.0011	0.0023	0.0023	0.0013	0.0011	0.0023	0.0023
4	0.0013	0.0011	0.0023	0.0023	0.0031	0.0026	0.0054	0.0054
Ę	0.0014	0.0012	0.0025	0.0025	0.0014	0.0012	0.0025	0.0025
(	0.0024	0.0021	0.0043	0.0043	0.0024	0.0021	0.0043	0.0043
7	0.0024	0.0021	0.0043	0.0043	0.0024	0.0021	0.0043	0.0043